



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application

Inventor: Jeffrey W. Carr
Appln. No.: 10/002,035
Confirm. No.: 5043
Filed: November 1, 2001
Title: APPARATUS AND METHOD
FOR ATMOSPHERIC PRESSURE
REACTIVE ATOM PLASMA
PROCESSING FOR SHAPING
OF DAMAGE FREE SURFACES

PATENT APPLICATION

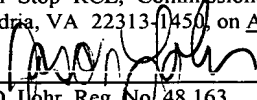
Art Unit: 1746
Examiner: Allan W. Olsen

Customer No. 23910

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CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop RCE, Commissioner for Patents, Art Unit 1746, PO Box 1450, Alexandria, VA 22313-1450, on August 8, 2003.


Jason D. Lohr, Reg. No. 48,163
Signature Date: August 8, 2003.

(Attorney Signature)

RESPONSE "C" TO OFFICE ACTION UNDER 37 C.F.R. § 1.116

Mail Stop RCE
Commissioner for Patents
Art Unit 1746
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This RESPONSE "C" is in reply to the final Office Action mailed April 25, 2003. No additional fee is required with this response.

Amendments

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of the claims which begins on Page 2 of this paper.